

Docket No. 206645US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Takao NOGUCHI, et al.

FILING DATE: Herewith

FOR: MULTILAYER THIN FILM, ITS PREPARATION METHOD AND ELECTRONIC DEVICE

LIST OF INVENTORS' NAMES AND ADDRESSES

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

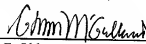
Listed below are the names and addresses of the inventors for the above-identified patent application.

Takao NOGUCHI	Tokyo, Japan
Yoshihiko YANO	Tokyo, Japan
Hisatoshi SAITOU	Tokyo, Japan
Hidenori ABE	Tokyo, Japan

A declaration containing all the necessary information will be submitted at a later date.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



Norman F. Oblon
Registration No. 24,618

C. Irvin McClelland
Registration Number 21,124

1
2
3
4
5
6
7
8
9
10
11
12
13
14
15
16
17
18
19
20
21
22
23
24
25
26
27
28
29
30
31
32
33
34
35
36
37
38
39
40
41
42
43
44
45
46
47
48
49
50
51
52
53
54
55
56
57
58
59
60
61
62
63
64
65
66
67
68
69
70
71
72
73
74
75
76
77
78
79
80
81
82
83
84
85
86
87
88
89
90
91
92
93
94
95
96
97
98
99
100



22850

Tel. (703) 413-3000
Fax. (703) 413-2220
OSMMN 11/98